

Via EFS

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re: Patent Application of :  
Masayuki Takashima :  
:  
Patent No.: 7,176,173 : Issued: February 13, 2007  
:  
Appln. No.: 10/659,190 : Filed: September 10, 2003  
:  
For: WASHING LIQUID FOR SEMICON- : Attorney Docket No.  
DUCTOR SUBSTRATE AND METHOD OF : 683261-1 (F-283-US/JYS)  
PRODUCING SEMICONDUCTOR DEVICE:

**TRANSMITTAL LETTER**

Although it is Applicant's opinion that the claims filed by way of amendment are substantially embraced in the statement of invention or in the claims originally filed, Applicant herewith files a Supplemental Declaration for precautionary purposes under 37 CFR 1.67.

Respectfully submitted,

February 22, 2007 By: W. W. Schwarze  
(Date)

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WWS/DCM  
Enclosure